



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**

Donald L. Yates

**Serial No.:** 10/633,069

**Filed:** August 1, 2003

**For:** METHOD OF REDUCING WATER  
SPOTTING AND OXIDE GROWTH ON A  
SEMICONDUCTOR STRUCTURE

**Confirmation No.:** 4229

**Examiner:** F. Stinson

**Group Art Unit:** 1746

**Attorney Docket No.:** 2269-3375.9US  
(95-0999.08/US)

**Notice of Allowance Mailed:**

January 12, 2005

**NOTICE OF EXPRESS MAILING**

Express Mail Mailing Label Number: EL994823263US

Date of Deposit with USPS: April 7, 2005

Person making Deposit: Steve Wong

**AMENDMENT PURSUANT TO 37 C.F.R. § 1.312(a)**

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Please amend the above-referenced application as follows:

**Amendments to the Specification** appear on page 3 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this paper.

**Amendments to the Drawings** appear on page 10 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

**Remarks** begin on page 11 of this paper.

An **Appendix** including amended drawing figures is attached following page 11 of this paper.